



**ELECTRONIC COPY**

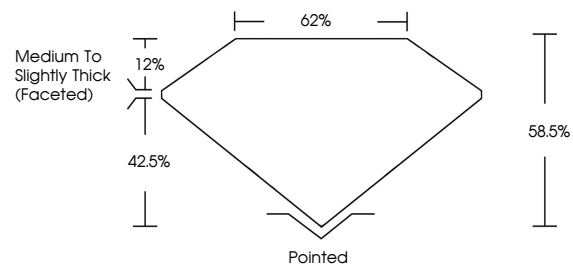
**LABORATORY GROWN DIAMOND REPORT**

June 6, 2026  
IGI Report Number **LG807632392**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **9.48 X 6.68 X 3.91 MM**  
**GRADING RESULTS**  
Carat Weight **1.54 CARAT**  
Color Grade **E**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG807632392**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**COLOR**

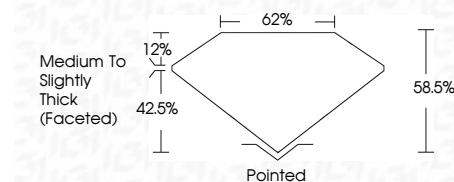
D E F G H I J Faint Very Light Light

**CLARITY**

| FL       | IF                  | VVS <sup>1-2</sup>          | VS <sup>1-2</sup>      | SI <sup>1-2</sup> | I <sup>1-3</sup> |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included         |



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**IGI**



June 6, 2026  
IGI Report No. **LG807632392**  
**OVAL BRILLIANT**  
Carat Weight **1.54 CARAT**  
Color Grade **E**  
Clarity Grade **VVS 2**  
Table **62%**  
Girdle **Medium to Slightly Thick (Faceted)**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG807632392**

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